### 506223710 08/27/2020

# PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
GUILEI WANG	08/26/2020
HENRY H. RADAMSON	08/26/2020
ZHENZHEN KONG	08/26/2020
JUNJIE LI	08/26/2020
JINBIAO LIU	08/26/2020
JUNFENG LI	08/26/2020
HUAXIANG YIN	08/26/2020

#### **RECEIVING PARTY DATA**

Name:	INSTITUTE OF MICROELECTRONICS, CHINESE ACADEMY OF SCIENCES
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Internal Address:	CHAOYANG DISTRICT
City:	BEIJING
State/Country:	CHINA
Postal Code:	100029

#### **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	17004173

#### **CORRESPONDENCE DATA**

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ATTORNEY DOCKET NUMBER:	IME-055
NAME OF SUBMITTER:	CE LI
SIGNATURE:	/Ce Li/

PATENT 506223710 REEL: 053613 FRAME: 0134

DATE SIGNED:	08/27/2020
Total Attachments: 9	
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## **ASSIGNMENT**

WHEREAS, We/I, Guilei WANG (citizen of China), residing at No. 3 Beitucheng West Road, Chaoyang District, Beijing 100029, P. R., China; Henry H. RADAMSON (citizen of Sweden), residing at No. 3 Beitucheng West Road, Chaoyang District, Beijing 100029, P. R., China; Zhenzhen KONG (citizen of China), residing at No. 3 Beitucheng West Road, Chaoyang District, Beijing 100029, P. R., China; Junjie LI (citizen of China), residing at No. 3 Beitucheng West Road, Chaoyang District, Beijing 100029, P. R., China; Jinbiao LIU, (citizen of China), residing at No. 3 Beitucheng West Road, Chaoyang District, Beijing 100029, P. R., China; Junfeng LI (citizen of China), residing at No. 3 Beitucheng West Road, Chaoyang District, Beijing 100029, P. R., China and Huaxiang YIN (citizen of China), residing at No. 3 Beitucheng West Road, Chaoyang District, Beijing 100029, P. R., China have invented certain new and useful improvements in and to the subject matter of:

#### SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

described in an application for United States Letters Patent, filed on <u>August 27, 2020</u>, and accorded Application No. <u>17/004,173</u>, which claims priority to Chinese App. Nos. <u>202010494852.6</u>, and Chinese App. No. <u>202010495562.3</u>, both filed on <u>June 3, 2020</u>;

AND, WHEREAS, INSTITUTE OF MICROELECTRONICS, CHINESE ACADEMY OF SCIENCES, organized under the laws of China, having a place of business located at No. 3 Beitucheng West Road, Chaoyang District, Beijing 100029, P.R. China, (hereinafter "ASSIGNEE"), is desirous of acquiring certain rights to the improvements and under the application;

NOW, THEREFORE, in consideration of good and valuable consideration, receipt of which is hereby acknowledged, We/I do hereby sell, assign and transfer unto said ASSIGNEE, its successors, assigns and legal representatives, our/my entire right, title and interest in and throughout the United States of America (including its territories and dependencies) and all countries foreign thereto in and to said improvements, said United States application, any other United States applications, including provisional, divisional, renewal, substitute, continuation, reexamination and reissue applications, based in whole or in part on said United States application or in whole or in part on said improvements, any foreign applications, including international and regional applications, based in whole or in part on any of the aforesaid United States applications or in whole or in part on said improvements, and in and to any and all letters patent, including extensions thereof, of any country which have been or may be granted on any of the aforesaid applications or on said improvements or any parts thereof;

AND We/I hereby authorize and request our/my agents, Goodwin Procter LLP, whose address is 1900 N Street, N.W.; Washington, DC 20036, to insert hereon any identification necessary or desirable for recordation of this document, including the filing date and application number of said application when known.

AND We/I hereby agree for ourselves/myself and our/my heirs, executors and administrators to execute without further consideration any further documents and instruments which may be necessary, lawful and proper in the prosecution of said above-referenced

application or in the preparation or prosecution of any continuing, substitute, divisional, renewal, reexamination or reissue application or in any amendments, extensions or interference proceedings, or other applications for patents of any region or country, that may be necessary to secure to ASSIGNEE its interest and title in and to said improvements or any parts thereof, and in and to said several patents or any of them;

AND We/I hereby covenant for ourselves/myself and our/my legal representatives, and agree with said ASSIGNEE, its successors and assigns, that We/I have granted no right or license to make, use, sell or offer to sell said improvements, to anyone except said ASSIGNEE, that prior to the execution of this deed, our/my right, title and interest in said improvements had not been otherwise encumbered, and that We/I have not and will not execute any instrument in conflict therewith:

AND We/I do hereby authorize and request the Director of the United States Patent and Trademark Office to issue any and all letters patent which may be granted upon said United States applications, or upon said improvements or any parts thereof when granted, to said ASSIGNEE;

### AND I hereby declare:

- a) The above-identified application was made or authorized to be made by me.
- b) I believe that I am the original inventor or an original joint inventor of a claimed invention in the application.
- c) I hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both.

IN WITNESS WHEREOF, We/I have hereunto set our/my hands and seals.

[signatures start on next page]

2020	
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On this <u>26th</u> dan	on of that name, who
	ziospig ire) gping FAN ame)
	ire)  WANG
	gping FAN ame)

08/26/2020				KA RadanSi	\$ \$ <sub>\$6</sub>
Date		_	Ħ	enry H. RADAM	ISON
appeared Henry H. RADA		AMSON,	to me know	wn and known to	, 2020, before me personally me to be the person of that name, ged the same to be of his free act
				Witnessed b	y Fon Zhorging (Signature)
					Zhengping FAN (Print Name)
				Witnessed b	(Signature)
					Hui WANG (Print Name)

	大り Zhenzhen KONG	
appeared <b>Zhenzhen KON</b>	26th day of <u>August</u> , Go, to me known and known to me to be going instrument, and acknowledged the	e the person of that name, who
	Witnessed by	Ton Zhorgoig (Signature) Zhengping FAN
	Witnessed by	(Print Name)
		Hui WANG (Print Name)

08/26/2020			nd S	k 1/2/25 -	
Date			Jun	jie LI	
	ie LI, to 1	me known	and known to	o me to be the pe	2020, before me personally rson of that name, who signed o be of his free act and deed.
				Witnessed by	Ton Zhorsprif (Signature)
					Zhengping FAN (Print Name)
				Witnessed by	(Signature)
					Hui WANG (Print Name)

08/26/2020	刘仓旭	
Date	Jinbiao LIU	
Jinbiao LIU, to me	is <u>26th</u> day of <u>August</u> , 2020, I known and known to me to be the person instrument, and acknowledged the same to be	of that name, who signed and
	Witnessed by	Fan Zhorging (Signature)
		Zhengping FAN (Print Name)
	Witnessed by	(Signature)
		Hui WANG (Print Name)

08/26/2020 Date	Junfeng LI	<u> </u>			
	On this <u>26th</u> day of <u>August</u> , nfeng LI, to me known and known to me to be the pe e foregoing instrument, and acknowledged the same to	rson of that name, who signed			
	Witnessed by	Fon Zhonging  (Signature)  Zhengping FAN			
	Witnessed by	(Print Name)			
		Hui WANG (Print Name)			

08/26/2020 Date	<u>操名词</u> Huaxiang YIN	
appeared Huaxiang YIN	26th day of <u>August</u> , to me known and known to me to be egoing instrument, and acknowledged the	the person of that name, who
	Witnessed by	Fan Zhorging (Signature)
		Zhengping FAN (Print Name)
	Witnessed by	(Signature)
		Hui WANG (Print Name)

**RECORDED: 08/27/2020**